DECLARATION FOR PATENT APPLICATION AND POWER OF ATTORNEY

(Under 37 CFR § 1.63; includes reference to PCT International Applications)

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention ENTITLED:

NANOWIRE ASSISTED LASER DESORPTION/IONIZATION MASS SPECTROMETRIC ANALYSIS

the specification	n of which:				
	PCT Application No. P	Continuation or Continuation o	ntinuation-in-Part or Div 38, filed March 15, 2005 wo2005/088293 on Sep	5	<u>15</u>
•	y state that I have review laims, as amended by any			e-identified spec	cification,
	wledge the duty to disclobe material to patentabi				
application(s) for one country other the	y claim foreign priority to patent or inventor's center than the United State patent or inventor's certinan the United States of an eapplication(s) on which	ertificate or of any Fortificate or all listed by the ficate or any PCT I America filed by m	CT International application of the control of the	tion(s) designatified below any designating at	ting at least y foreign least one
Prior Foreign/P	CT Application(s) [list a	dditional application	ons on separate page]:	Priority Cl	laimed:
Country (or KR	PCT) Application 10-2004-		Filed (Day/Month/Year) 17 / March / 2004	_	No
I hereb	y claim the benefit under	r 35 U.S.C. §119(e)	of any United States app	plication listed	below:
(Applic	cation Number)	(Filing Date)			
	y claim the benefit under tional application(s) desi	•	•	-	•

or PCT international application(s) designating the United States of America that is/are listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in that/those prior application(s) in the manner provided by the first paragraph of Title 35, United States Code § 112, I acknowledge the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

930086-2038

Prior U.S. (or U.S.-designating PCT) Application(s) [list additional applications on separate page]:

U.S. Serial No.: Filed (Day/Month/Year) PCT Application No. Status (patented, pending, abandoned)

Ronald R. Santucci 28,988 , and Frommer Lawrence & Haug LLP, or their duly I hereby appoint , Registration No. appointed associate, my attorneys, with full power of substitution and revocation, to prosecute this application, to make alterations and amendments therein, to file continuation and divisional applications thereof, to receive the Patent, and to transact all business in the Patent and Trademark Office and in the Courts in connection therewith, and to insert the Serial Number of the application in the space provided above, and specify that all communications about the application are to be directed to the following correspondence address: Ronald R. Santucci , Esq. c/o FROMMER LAWRENCE & HAUG LLP Direct all telephone calls to: (212) 588-0800 to the attention of: 745 Fifth Avenue New York, NY 10151 Ronald R. Santucci

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

INVENTOR(S): 8-30-06 Signature: Full name of sole or first inventor: CHOI, Heon Jin 204-1507 Hanjin Apt., 609-1 Donam-dong, Seongbuk-gu, Residence: Seoul 136-060, Republic of Korea Citizenship: Korea Tym, Joe - aml Signature: Date: Full name of 2nd joint inventor (if any): PYUN, Jae Chul Korea Institute of Science and Technology, 39-1, Hawolgok 2-dong, Residence: Seongbuk-gu, Seoul 136-791, Republic of Korea Citizenship: Korea